504716555 01/05/2018

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT4763277

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
YONG LI	01/04/2018

RECEIVING PARTY DATA

Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (SHANGHAI) CORPORATION		
Street Address:	18 ZHANGJIANG ROAD, PUDONG NEW AREA		
City:	SHANGHAI		
State/Country:	CHINA		
Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (BEIJING) CORPORATION		
Street Address:	NO. 18 WEN CHANG RD., ECONOMIC-TECHNOLOGICAL DEVELOPMENT AREA, DAXING DISTRICT		
City:	BEIJING		
State/Country:	CHINA		

PROPERTY NUMBERS Total: 1

Property Type	Number		
Application Number:	15863581		

CORRESPONDENCE DATA

Fax Number:

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 571-379-9468

Email: uspto@anovalaw.com

Correspondent Name: ANOVA LAW GROUP C/O SMIC

Address Line 1: 21495 RIDGETOP CIRCLE

Address Line 2: SUITE 300

Address Line 4: STERLING, VIRGINIA 20166

ATTORNEY DOCKET NUMBER:	00158.0495.00US
NAME OF SUBMITTER:	WENDY LIN
SIGNATURE:	/Wendy Lin/
DATE SIGNED:	01/05/2018

PATENT REEL: 044548 FRAME: 0152

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Total Attachments: 2

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PATENT REEL: 044548 FRAME: 0153

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ASSIGNMENT AND DECLARATION

WHEREAS I/We, the below named inventor(s) (hereinafter referred to as Assignor(s)) have made an invention entitled:
SEMICONDUCTOR STRUCTURE AND FABRICATION METHOD THEREOF
for which I/We executed an application for United States Letters Patent concurrently herewith or filed an application for United States Letters Patent on
WHEREAS, Semiconcuctor Manufacturing International (Shanghai) Corporation, a corporation of P. R. China whose post office address is 18 Zhangliang Road, Pudong New Area, Shanghai, China 201203, and Semiconductor Manufacturing International (Beijing) Corporation, a corporation of P. R. China whose post office address is No. 18. Wen Chang Rd., Economic-Technological Development Area Daxing District, Beijing, China, 100716 (hereinafter referred to as Assignee), is desirous of securing the entire right, title, and interest ir and to this invention in all countries throughout the world, and in and to the application for United States Letters Patent on this invention and the Letters Patent to be issued upon this application;
NOW THEREFORE, be it known that, for good and valuable consideration the receipt of which from Assignee is hereby acknowledged, I/We, as Assignor(s), have sold, assigned, transferred, and set over, and do hereby sell, assign, transfer, and set over unto the Assignee, its lawful successors and assigns, my/our entire right, title, and interest in and to this invention, provisional Application No
AND, I/WE HEREBY covenant that I/We have the full right to convey the interest assigned by this Assignment, and I/We have not executed and will not execute any agreement in conflict with this Assignment.
AND, I/WE HEREBY further covenant and agree that I/We will, without further consideration, communicate with Assignee, its successors and assigns, any facts known to me/us respecting this invention, and testify in any legal proceeding, sion all lawful pages when called upon to do so, execute

invention, and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver any and all papers that may be necessary or desirable to perfect the title to this invention in said Assignee, its successors or assigns, execute all divisional, continuation, and reissue applications, make all rightful paths and generally do everything possible to aid Assignee, its successors and assigns, to obtain and enforce proper patent protection for this invention in the United States and any foreign country, it being understood that any expense incident to the execution of such papers shall be borne by the Assignee, its successors and assigns.

AND, I/WE HEREBY authorize and request the attorneys l/we have empowered in the	
Declaration and Power of Attorney in this application, to insert here in parentheses (Application	1 No,
filed) the sling date and application number of said application when know	n.

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Furthe	er, as a belo	w named inver	itor, I hereb	y declare that:		
This c international a If the applicati	leclaration is pplication n on is not att	s directed to the umber_ ached hereto, t	application	attached hereto	or United State on d above or by the	s application or PCT
number as set	forth above	and/or the follo	owing.			,
The a	bove-identif	ied application	was made (or authorized to I	e made by me.	
I belie application.	ve that I am	the original inv	entor or an	original joint inv	entor of a claime	d invention in the
I have	reviewed a	nd understand	the content	s of the above-io	entified applicati	on including the
claims.						
37,Code of Fe information wh	deral Kegul Iich became	ations § 1.58 ii	ncluding for een the filin	continuation-in- a data of the ori	rial to patentabili part applications or application and	ty as defined in Title material d the national or
I herel 18 U.S.C. §10	oy acknowle 01 by fine o	dge that any w rimprisonment	illful false si of not more	atement made i than five (5) ye	n this declaration ars, or both.	is punishable unde
IN TE	STIMONY V	VHEREOF, I/W	e have here	unto set our har	ods,	
Inver Lega	itor 1 I Name:	Yong LI				
Signa	ature:	李勇//	ng Lì	Date:	3018-1-4	
Note: An applica accompany this list additional inv	torm or must	et (PTC/S8/14 o have been previo	requivalent) ously filed. (including naming theck the box belo	the entire inventive w and complete th	e entity, must e attached page(s) to
Additional in	ventors are t	peirg named on t	he supole	mental sheet(s) a	tacheo hereto	88.0
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